

Corrigendum to microstructure characterization and tensile properties of CMT-based wire plus arc additive manufactured ER2594 [materials characterization 169 (2020) 110671]

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The authors regret “The experimental set up shown in [Fig. 1](#) is wrongly provided in the manuscript”.

The correct file is provided for your kind reference and attached.

The authors would like to apologise for any inconvenience caused. DOI of original article: <https://doi.org/10.1016/j.matchar.2020.110671>

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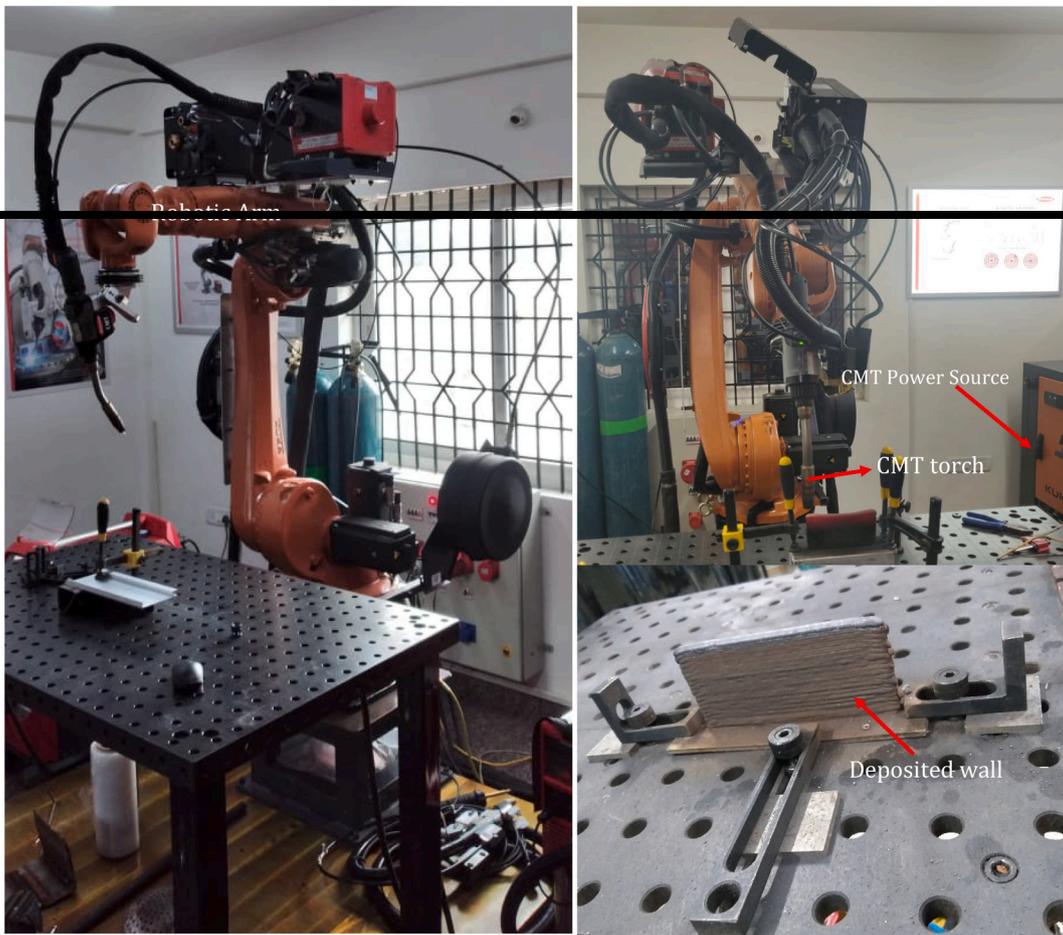


Fig. 1. Experimental setup of CMT-WAAM employed for depositing layers using ER2594.